

219288US-2 PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :  
YASUTAKA ITO ET AL. : ATTN: APPLICATION DIVISION  
SERIAL NO: 10/049,293 :  
FILED: February 11, 2002 :  
FOR: CERAMIC HEATER

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

IN THE CLAIMS

Please amend claims 3 and 4 to read as follows:<sup>1</sup>

*A.* 3. (Amended) The ceramic heater for heating a semiconductor wafer according to claim 1,

wherein said temperature-measuring means is a temperature-measuring element.

4. (Amended) The ceramic heater for heating a semiconductor wafer according to claim 1,

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<sup>1</sup>A marked-up copy of the claim amendments is attached hereto.